INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 2, 2024	
IGI Report Number	LG644499479
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	8.70 X 5.95 X 4.04 MM

GRADING RESULTS

Carat Weight	2.08 CARATS
Color Grade	E
Clarity Grade	VS 1

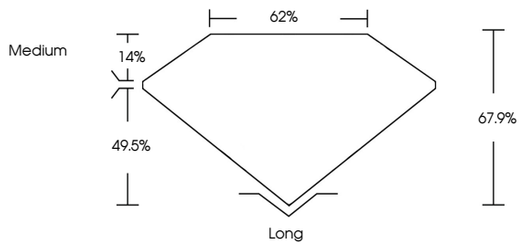
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG644499479

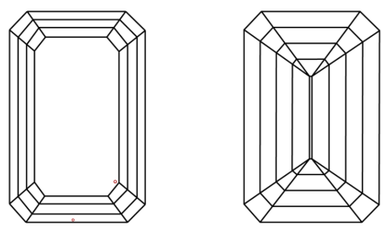
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG644499479
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

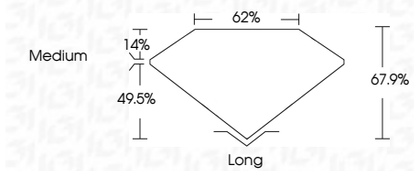
FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

LABORATORY GROWN DIAMOND REPORT

August 2, 2024
IGI Report Number LG644499479
Description LABORATORY GROWN DIAMOND
Shape and Cutting Style EMERALD CUT
Measurements 8.70 X 5.95 X 4.04 MM
GRADING RESULTS
Carat Weight 2.08 CARATS
Color Grade E
Clarity Grade VS 1



ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG644499479
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

August 2, 2024
IGI Report No LG644499479
EMERALD CUT
8.70 X 5.95 X 4.04 MM
Carat Weight 2.08 CARATS
Color Grade E
Clarity Grade VS 1
Depth 67.9%
Table 62%
Girdle Medium
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG644499479
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa